In the claims:

Kindly rewrite the claims as follows:

1. (Currently amended) Sluice system for a vacuum <u>coating</u> facility for coating substrates that can be moved through the vacuum coating <u>facility</u> in at least one direction of conveyance, <u>with comprising</u>:

a prevacuum sluice chamber to which a prevacuum pump system ean be detachably is connected by means of a first selectively activatable valve arrangement, characterized such that and a high-vacuum pump system (12) is detachably connected to the prevacuum sluice chamber (2) by means of a second selectively activatable valve arrangement (16) and , the second valve arrangement (16) can be being activated and deactivated inversely to the first valve arrangement (11).

- 2. (Currently amended) Sluice system according to Claim 1, eharacterized such that a-wherein the prevacuum pump system (6) exhibits comprises at least one Root pump (7) as a main pump (8) and at least one rotary slide-valve pump (9) as a backing pump (10).
- 3. (Currently amended) Sluice system according to Claim 1 or 2, characterized such that-wherein the high-vacuum system (12) exhibits comprises at least one turbo-molecular pump (13) as a main pump (14), and at least one backing pump arrangement (19), which corresponds to the a backing pump arrangement of the prevacuum pump system (12).
- 4. (Currently amended) Sluice system according to Claims Claim 1-to-3, eharacterized such that wherein the prevacuum pump system (6) can be detachably connected is selectively connectable to the high-vacuum system (12).
- 5. (Currently amended) Sluice system according to Claim 4, characterized such that wherein the prevacuum pump system (6) can be activated in such a way that it is directly is selectively connected to the prevacuum sluice chamber (2) in a first operating state and, alternatively to this, is activated in a second operating state as a backing pump arrangement (19) of the high-vacuum pump (12), whereby and wherein the high-vacuum pump system (12)

exhibits comprises a support pump (15), which is activated in the first operating state as a backing pump arrangement (19) of the high-vacuum pump system (12).

6. (Currently amended) Sluice system according to Claim 5, characterized such that the wherein a pressure side of the a main pump (14) of the high-vacuum pump system (12) is connected to the an intake side of the support pump (15) and detachably connected to the an intake side of the a main pump (8) of the prevacuum pump system (6) in parallel to the support pump (15) by means of a bypass line (17) and a bypass valve (18), whereby and wherein the bypass valve (18) can be is activated inversely to the first valve arrangement (11).